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PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Ogata et al.

Art Unit: 1712

Application No.: 10/748,190

Examiner: Marc S. Zimmer

Filed: December 31, 2003

Docket: 1608-3 DIV

Confirmation No.: 5536

For: POSITIVE RESIST COMPOSITION  
AND BASE MATERIAL CARRYING  
LAYER OF THE POSITIVE RESIST  
COMPOSITION

Dated: February 5, 2007

I hereby certify this correspondence is being deposited with  
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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: February 5, 2007

Signature: Marcy H. Mancuso 

**AMENDMENT AND RESPONSE PURSUANT TO 37 C.F.R. §1.111**

Sir:

This is in response to the final Office Action mailed December 4, 2006, a reply to which is due by March 4, 2007, please amend the above-identified application as follows. As this response is being filed within two months of the mailing of the Office Action, a reply by the three month due date is respectfully requested. As February 4, 2007, fell on a Saturday, this Amendment and Response to Office Action is timely filed under the two-month rule on Monday, February 5, 2007.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 3 of this paper.